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First Named Inventor	Larry C. Olsen	
Art Unit	3744	
Examiner Name	Not yet assigned	

SPATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date.

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
		FORF	IGN PATENT DOCUME	ENTS

Name of Examiner's Cite No. Country Number **Publication Date** Initials* (optional) **Applicant or Patentee** Examiner's Cite No. OTHER DOCUMENTS (optional) Initials* Final Office action from the U.S. Patent and Trademark Office for U.S. Patent Application No. 10/726,744, dated February 29, 2008. Stölzer, M. et al., "Optimisation of p - (Bi_{0.25}Sb_{0.75})₂Te₃ and n - Bi₂(Te_{0.9}Se_{0.1})₃ Films for Thermoelectric Thin Film Components," 2nd Symposium on Thermoelectrics-Materials, Processing Techniques & Applications, 5 pages (1994).

EXAMINER SIGNATURE:	DATE CONSIDERED:

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